AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yeo, et al. Docket No.: TSM03-0847

Serial No.: 10/826,602 Art Unit: 1756

Filed: April 16, 2004 Examiner: Raymond, Brittany L.

For: Lithography Apparatus for Manufacture of Integrated Circuits

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated October 2, 2007, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.